

Vacuum Requirements for GSI and FAIR

Accelerator Seminar A. Krämer (GSI Darmstadt)

28.01.2021

Outline



- Introduction
 - Ion Beam Lifetime and Vacuum Pressure
 - Pumping Surfaces
 - Dynamic vacuum
- GSI & FAIR Vacuum Requirements
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 - CRYRING
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 - FAIR Vacuum Systems
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 - HEBT
 - SuperFRS
 - p-Linac
 - pbar Separator
 - CR
 - HESR

Ion Beam Lifetime



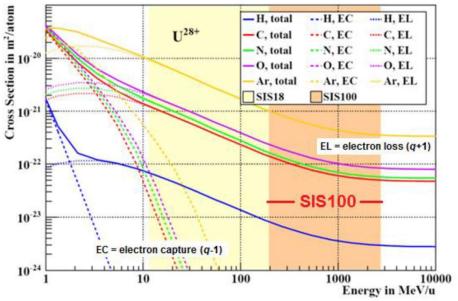
- Ions collide with a certain probability on their way through the accelerator with residual gas atoms / molecules.
- particles could undergo Coulomb scattering and/or undergo charge (electron capture or electron loss (ionization)).
- > Charge exchanged ions will be lost due to charge separation in the dipole magnets.
- Mainly a problem for storage rings and synchrotrons, where the ions travel a long way.

$$\tau(E) = [\nu n_x \sigma_x(E)]^{-1}$$

- $\tau(E)$ Lifetime
- v Ion velocity
- n_x particle density of residual gas atoms / molecules x
- $\sigma_x(E)$ Charge exchange cross section (dependent on ion energy)

Charge exchange cross sections are higher for heavier gas atoms/molecules.

➢ to guarantee required lifetime, reduce base pressure in accelerator and avoid heavy components (like Argon) in residual gas!



L Bozyk, Proc. IPAC2016, MOPOY055, ISBN 978-3-95450-147-2

Achievable Ultimate Pressure



The ultimate pressure in a vacuum system is determined by:

- Desorption Material property dependent of pre-treatment (e.g. cleaning, bake-out,...)
- Diffusion Material property
- Permeation Material property
- Leaks (real und virtual) dependent of sealing, manufacturing and assembly technology
- Pumps back streaming, ultimate pressure of pump
- Process gases
- Installed pumping throughput

$$p_{ultimate} = \frac{Q_{desorption} + Q_{diffusion} + Q_{permeation} + Q_{leak} + Q_{process}}{S_{eff}}$$

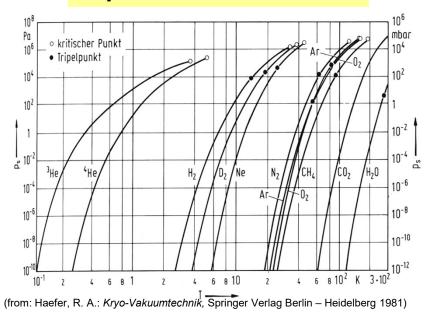
 $Q_{desorption/diffusion} \sim 10^{-13} \text{ (mbar I)/(s cm}^2)$ $Q_{permeation} \sim 10^{-14} \text{ (mbar I)/(s cm}^2)$ $Q_{leak} \sim 0$ (in ideal case) $Q_{process}$: dependent of the process, in accelerators zero (except gas targets and stripper)

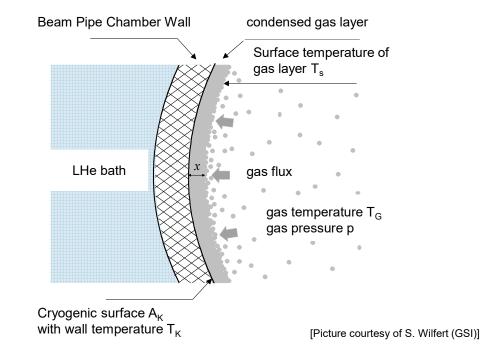
- Careful choice of material: e.g. Stainless steel, Aluminium, Titanium, Copper, ceramics (e.g. Al2O3)
- Proper cleaning methods
- Thermal degassing (vacuum firing & bake-out)
- Surface treatment (cleaning procedures, possibly polishing, coating)
- Problem to increase pumping speed due to conductance limitations in accelerators!
- Solution: converting the chamber wall into a pump (distributed instead of lumped pumping)!

Pumping on cryogenic surfaces



Vapour Pressure Curves





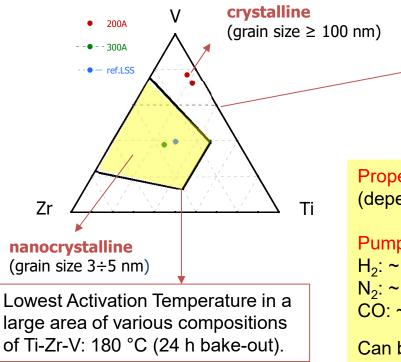
- Use of liquid Helium (LHe) existing in superconducting magnets to cool vacuum chamber.
- Surface temperature T = 1.9...4.2K
- Pressure in the range < 10^{-13} mbar achievable
- · Gases will freeze at the chamber walls
- Conventional, external vacuum system not necessary and inefficient

Pumping with NEG Coating

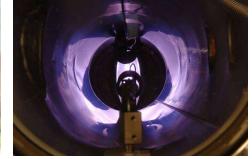


NEG (Non Evaporable Getter): Alloy of Titanium, Zirconium and Vanadium developed by CERN

- deposited via Magnetron Sputtering on the inner wall of the vacuum chamber (film thickness 1-3μm)
- Thermal activation under vacuum gives a pumping surface for all chemical active gases (not Methane, Noble gases)







Properties of NEG coating (dependent on surface roughness of coating)

Pumping speed:

 H_2 : ~ 0.35 – 1.3 l/s cm² N₂: ~ 0.17 – 0.34 l/s cm² CO: ~ 8 – 10.4 l/s cm²

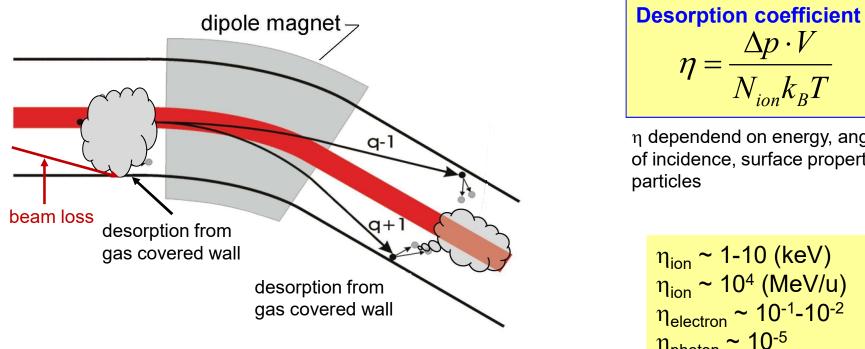
Capacity:

 $N_2: \ 1.5 x 10^{14} - 1.5 x 10^{15} \ mol/cm^2 \\ CO: \ 8 x 10^{14} - 8 x 10^{15} \ mol/cm^2$

Can be reactivated up ~30 times, performance can be kept up to 90% by applying higher temperatures and/or longer activation times

Dynamic Vacuum Effects





 η dependend on energy, angle of incidence, surface properties,

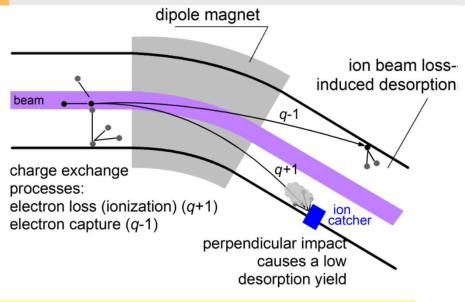
 $\eta_{ion} \sim 1-10 \text{ (keV)}$ $\begin{array}{l} \eta_{ion} \thicksim 10^4 \mbox{ (MeV/u)} \\ \eta_{electron} \thicksim 10^{\text{-1}} \mbox{-10}^{\text{-2}} \end{array}$ $\eta_{photon} \sim 10^{-5}$

Losses due to charge exchange or initial losses at injection drive a local pressure bump due to ion induced desorption

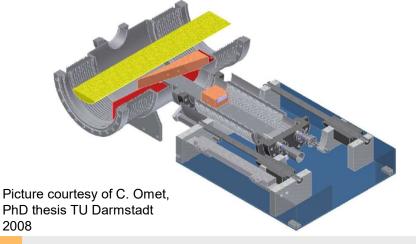
- Self amplification can develop up to complete beam loss
- Maximum number of accelerated ions is limited \rightarrow beam intensity limitation
- Can't be cured by higher pumping speed only!

Ion Catcher System





Prototype Collimator (Ion Catcher)@SIS18



Counter Measure: Controlled collection of charge-exchanged ions at exactly-defined ring positions using an ion catcher system

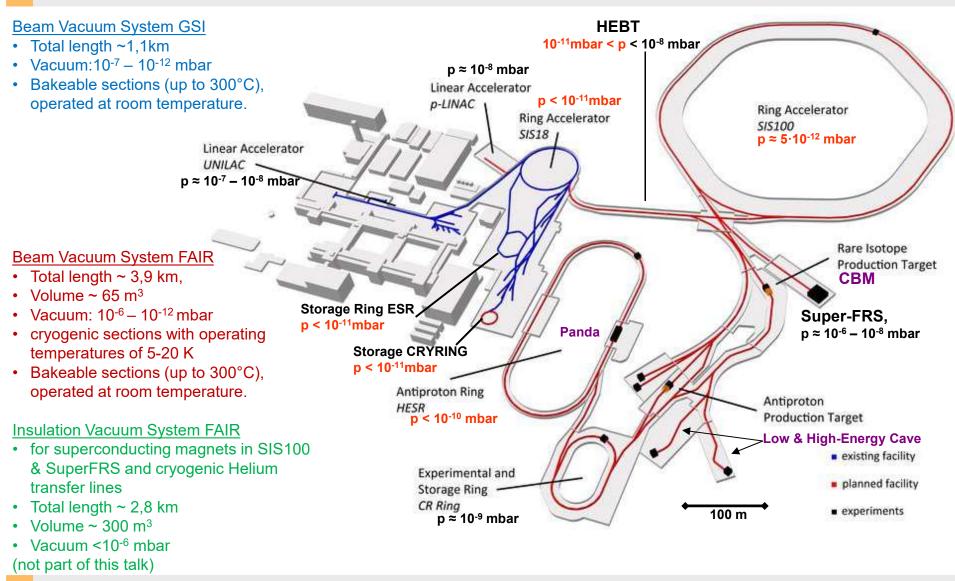
 Controlled catching of ionized ions on surfaces with low desorption yield (gold) → most ionized ions are caught by the ion catcher

 Provide increased pumping speed in surrounding chamber to quickly remove desorbed gases

→ dynamic vacuum effects are suppressed effectively

GSI&FAIR Vacuum Requirements



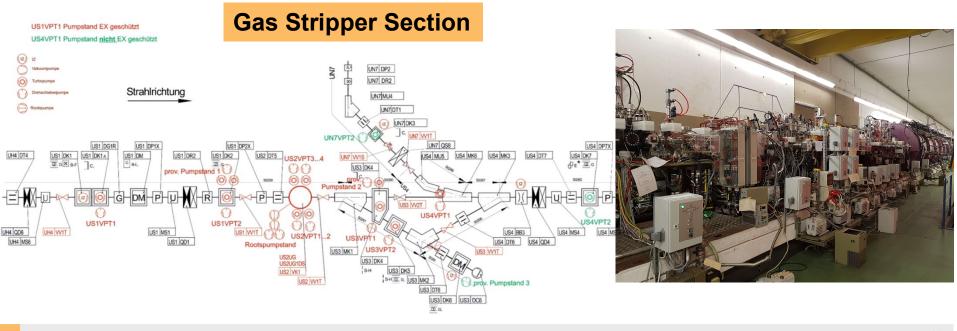


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Vacuum System of UNILAC, EH & TK

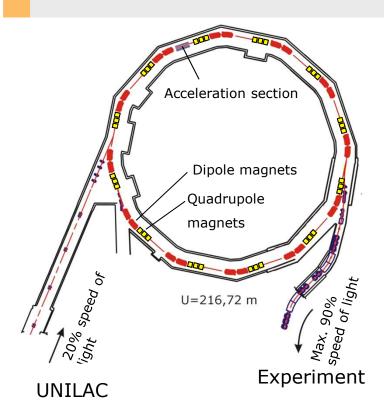


- Operation pressure: ~1x10⁻⁶ 5x10⁻⁸ mbar (depending on section, partially higher during stripper operation)
- 55 independent High Vacuum Sections separated by Viton sealed gate valves
- Ion Getter- (~100pcs.) & Turbo Molecular Pumps (~70pcs.) with Roughing Pumps (Rotary Vane Pumps, Roots Pumps,...)
- UNILAC-Tanks: large Volumes, Copper coated
 - additional medium vacuum system for protection of critical metal seals and for static relief of large dividing walls
- Beam transport lines (outside of tanks): narrow, long tubes and chambers made out of stainless steel with small volumes and surfaces.



Vacuum System of SIS18





- Circumference=216 m
- Magnets up to 1.8 T (18Tm magn. rigidity)
- Ramp rate: 10T/s

- Operating pressure ~10⁻¹¹ mbar
- Bakeable up to 250°C
- 7 Vacuum Sections
- Ion Getter Pumps (57pcs.), Titan Sublimation Pumps, NEG wafer modules, and NEG coating, TMP only during Roughing and Bakeout
- 9 All-Metal Valves
- Apertures:
 - Dipole: 190 x 70 mm²,
 - Quadrupole: 200 x 116 mm,
 - Pumping- & Diagnostic Chambers: Ø=200mm
- Vacuum Diagnostics:
 - 31 Total Pressure Gauges (Extractor)
- Upgrade Measures: additional pumping speed with NEG Cartridge pumps

SIS18: Dipole & Quadrupole Chamber Design



Problem:

Fast ramping of the magnets induces eddy currents

- The chamber walls are heated => no problem here
- Generation of additional harmonics in field.

Chamber design was optimized in terms of:

- field quality (additional harmonics)
- beam dynamic aspects (e.g. impedances)

Solution:

- Thin-walled chamber (d = 0.3 mm) with ribs for stiffening
- Stainless steel 1.4429 with $\mu_r \leq 1.005$

Quadrupole Chamber



NEG coating SIS18



NEG coating of all dipole and quadrupole chambers (in total about 65% of the surface) done at GSI



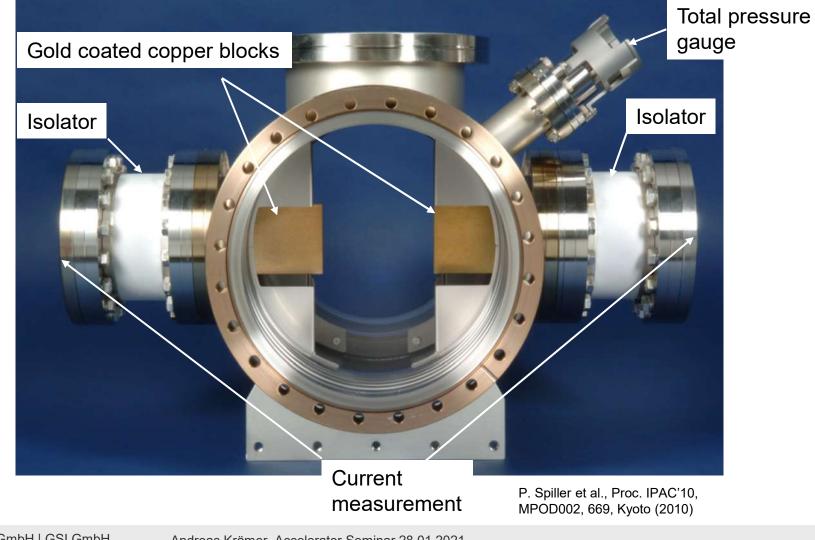


CERN Patent, Technology transfer and licence agreement between CERN and GSI in 2005
 Two Coating facilities at GSI

Collimators/Ion Catcher SIS18

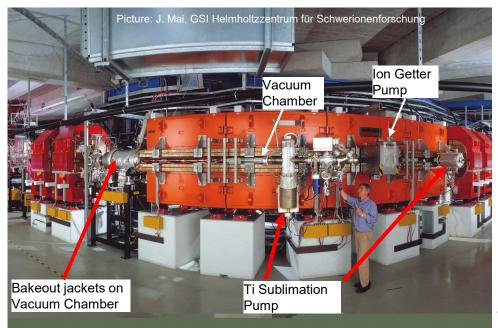


11 collimators are installed in SIS18

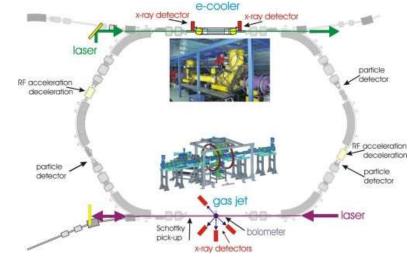


Vacuum System of Experimentierspeicherring (ESR)





- Operating pressure: 10⁻¹¹ to 10⁻¹² mbar
- Bakeable up to 300°C
- 4 Vacuum Sections
- Ion Getter Pumps (41pcs.), Titan Sublimation Pumps, TMP only during Roughing and Bakeout
- All-Metal Valves
- Vacuum diagnostics:
 - 13 Total Pressure Gauges (Extraktor) & 3 RGAs



Circumference 108 m Apertures:

- Dipole: 380 x 140 mm²,
- Quadrupole: 200 x 116 mm,
- Pumping- & Diagnostic Chambers: Ø=200mm

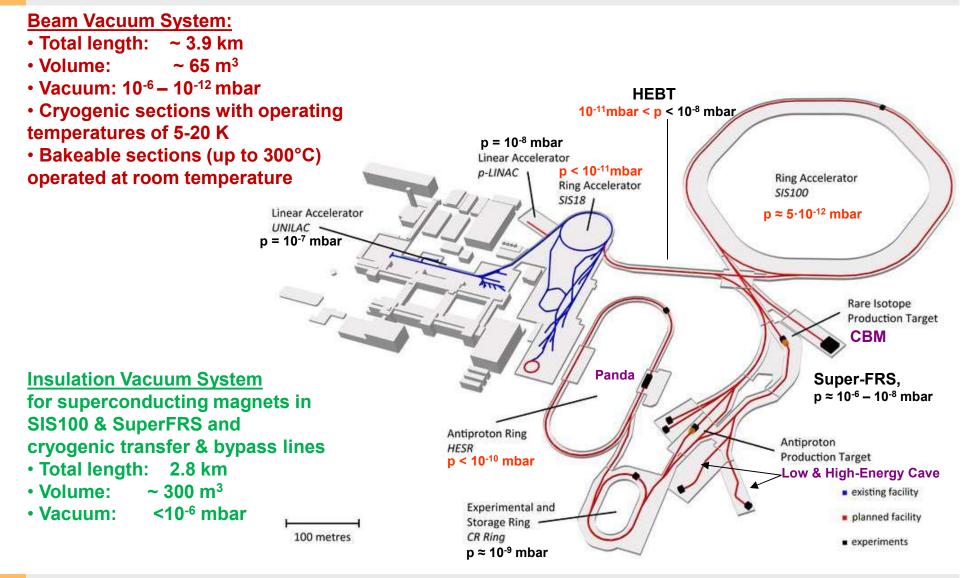
Vacuum System of CRYRING@ESR



Circumference Magnetic rigidity Highest energy for		Beam from ESR, E ~ 10MeV/u	
Magnet ram Vacuum pres Ion source (s	Bakeable up to 300°C Operating pressure: 10 ⁻¹¹ to 10 ⁻¹² mbar 13 Vacuum Sections Ion Getter Pumps (19pcs.) NEG Pumps (stripes, only activated via external bake-o	out)	
e-Cooler •	All-Metal ValvesVacuum diagnostics:12 Extraktor Type Gauges		
	 7 Pirani Gauges 12 Cold Cathode Gauges 2 Wide Range Gauges 		NIS n Source
·	 3 RGA Upgrade Measures: NEG coating of chambers & additionand NEG/IGP 	onal NEG Cartridges	
Ring Acceleration Structure		Section	

FAIR Vacuum Requirements





Principles and Status of System Design



- 1. The concept for the design of the vacuum system is **based on the operation experience** with existing GSI accelerators.
- 2. Use of standard components (catalogue items) for pumps, gauges and valves, no further development from manufacturer needed
- 3. In UHV systems with very low gas load, **only capture pumps** for keeping up the vacuum.
- 4. Keep all **electronics out of the accelerator tunnel** and install controllers and controls racks in dedicated electronic/supply rooms.
 - Operation experience at GSI shows a high failure rate of active vacuum gauges and gauge controllers inside of the accelerator tunnel:
 - In the HEST (high energy beam transport lines at GSI) we have to exchange about 10% of active wide range gauges per year.
 - > In case of a failure of the electronics the controller can be changed without access to the tunnel
 - Iong cables (power and signal) for all devices required

Status:

- The system design is **95% finalized** yet.
- Therefore the concepts, types and numbers of components may slightly change in one or the other place during finalization of the system design.

Properties of Vacuum Chambers



- All vacuum chambers will be made out of stainless steel grades: 1.4301, 1.4306/1.4307, 1.4404, 1.4429, 1.4435, Böhler P506
- Most of the flanges will be ConFlat type flanges with Cu-sealing
- Flange material: 1.4429 ESU, 1.4307
- Dimensions of the flanges: DN40 DN450
- High complexity of accelerators, high number of different components

- → Magnetic Permeability for magnet vacuum chambers: ≤1.01
- \implies Outgassing rate: $\leq 5 \times 10^{-10}$ mbar I/s/cm² ($\leq 1 \times 10^{-12}$ mbar I/s/cm², baked)
- \implies Leak rate: < 1x10⁻¹⁰ mbar l/s
- Vacuum firing to reduce stress and magnetic permeability after welding and – for bakeable machines – low hydrogen outgassing rates

Pumping Concept Beam Vacuum



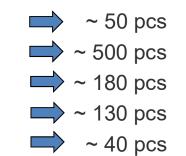
For roughing and during bake-out:

- Mobile & fixed stand alone pumping stations consisting of a turbomolecular pump, roughing pump & periphery
- \Rightarrow ~140 pcs for beam vacuum (~50 fixed, ~90 mobile)

For Keeping the Vacuum:

- Fixed Turbomolecular Pumps with Roughing Pumps (Super-FRS and p-Linac)
- Ion Getter Pumps (contract with Agilent Technologies)
- NEG/IGP Combination Pumps (contract with SAES getters)
- NEG Cartridge Pumps (contract with SAES getters)
- NEG wafer modules
- Cryosorption Pumps in SIS100 (design by GSI and built by ILK Dresden) 85 pcs
- NEG Coating of Chambers (done by GSI or external partners)
- Use of cryogenic wall pumping (cryopumping) in SIS100.

Pumping speed and detailed type of pumps based on vacuum pressure calculations and vacuum requirements.



Sectorization of Beam Vacuum System



- The beam vacuum system will be divided into 169 sections separated by gate valves.
- Length of sectors given by physical constraints (cold or warm sectors, branching beam line, maintenance,...).
- Type of valve (all-metal or Viton) defined by radiation level and requirements for bake-out.
 - HEBT: 46 sectors
 - SIS100: 46 sectors
 - CR/TCR1: 8 sectors
 - p-Linac: 8 sectors
 - p-bar Separator: 2 sectors
 - Super-FRS: 37 sectors
 - HESR: 22 sectors

Each sector can be pumped down and operated individually.

System Design – Vacuum Diagnostics



Keep all **electronics out of the accelerator tunnel** and install controllers and controls racks in dedicated electronic/supply rooms.

- Operation experience at GSI shows a high failure rate of active vacuum gauges and gauge controllers inside of the accelerator tunnel:
 - In the HEST (high energy beam transport lines at GSI) we have to exchange about 10% of active wide range gauges per year.
 - During high intensity runs in SIS18 almost 50% of the controllers for passive ion gauges (extractor type) failed. In SIS18 all extractor gauge controllers were removed out of the tunnel.
- In case of a failure of the electronics the controller can be changed without access to the tunnel
- Iong cables (power and signal) for all devices required

Vacuum Diagnostics Beam Vacuum

Use of passive gauges with dedicated controllers!

Total Pressure (type depending on the pressure range)

- Penning/Cold Cathode Gauges
- Pirani Gauges (at least one per vacuum sector) → ~ 200 pcs
- Hot Cathode Ion Gauges

Some of these types have to be radiation hard! Some Cold Cathode Gauges will be installed in cryogenic environment.

Partial Pressure

Residual Gas Analyzer (only in rings)







Insulation Vacuum



- VAC is responsible for the pumping and diagnostics of the insulation vacuum for:
 - super conducting magnets in SIS100 and Super-FRS
 - the cryogenic transfer lines and local cryogenics.
- Considered to be a "dirty" vacuum: high content of water and hydrocarbons
- Roughing with mobile & fixed stand alone Pumping Stations consisting of a Turbomolecular Pump, Roughing Pump & peripheral equipment
- Pump down to 10⁻² mbar before cool down starts, when magnets/He lines are cold, pumping stations will be valved off. Mobile stations will be removed.
- To keep the machines running in the case of a minor leakage in the insulation vacuum, one fixed pumping station per insulation vacuum sector foreseen.

Vacuum Controls and Bake-Out System: Industrial Control System



Realisation of vacuum controls and vacuum bake-out system is a close collaboration between Controls Department and Vacuum department:

- Controls Department is responsible for controls hard- and software
- Vacuum Department is responsible for vacuum hardware controllers (pumps, gauges, ...)

Control system implemented on CRYRING as a prototype for the FAIR vacuum control system (operational since 2017).

UNILAC vacuum control system upgraded in 2019 to FAIR standards.

The operational experience gained here, is taken into account for the design of FAIR.

Vacuum Control System Principles



The Vacuum control system and the vacuum bake-out systems are industrial control systems based on:

- Siemens SIMATIC S7 PLC's
- WinCC OA SCADA System running on CentOS LINUX server
- UNICOS framework from CERN, which provides automatic code generation for PLC and SCADA database
- Communication between SCADA server and PLC's via ACC network
- Communication between PLC's via completely isolated Ind. Ethernet
- SCADA HMI will be accessible from FCC as well as locally and from office machines
- Operation of vacuum gate valves and visualisation of the main pressure value of each section will be integrated into the GUI's of ACC control system
- Long term archiving will be available within the Controls Archive
- Short term archiving will be available within the WinCC OA SCADA

Vacuum Equipment to be controlled



Number of Vacuum Components to be controlled:

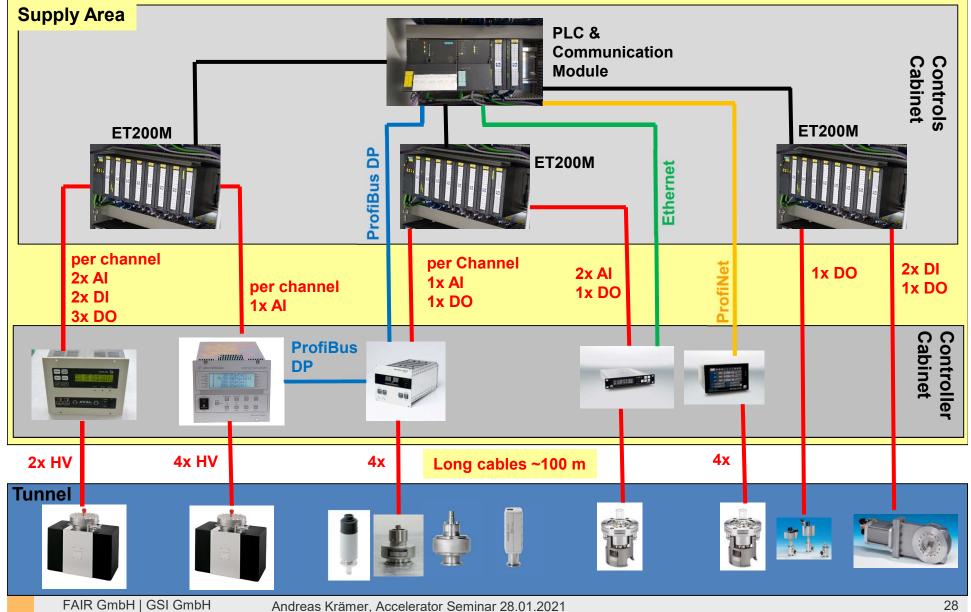
- Pumps: ~ 1250
- Gauges: ~ 1000
- Valves: ~ 500
- Bake-out Jackets, Thermocouples, thermal cut-out devices: ~ 4000 each

Chosen Interface/Protocol Type

- ProfiNet DP (to control the controllers) 1. Choice!
- ProfiBus (to control the controllers)
- Modbus TCP under evaluation
- in addition: Combination of Digital and Analogue I/O's (for redundancy, reboot,...)

The full functionality of the controller should be available via the interface!

Schematic Setup of Vacuum Controls (from CRYRING)



F(AIR

GSİ

Controller Cabinets for Vacuum Control System (example from UNILAC)



Front View Rear View with open doors ----------.......... ē ē ö

Controller Cabinets (UH011-UH22)

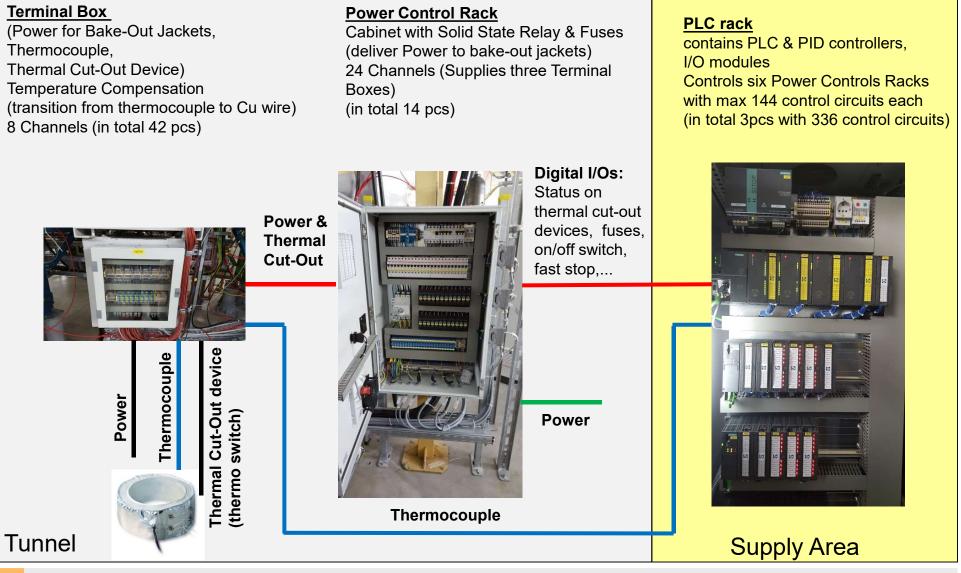
Controls Cabinets (for PLC components)



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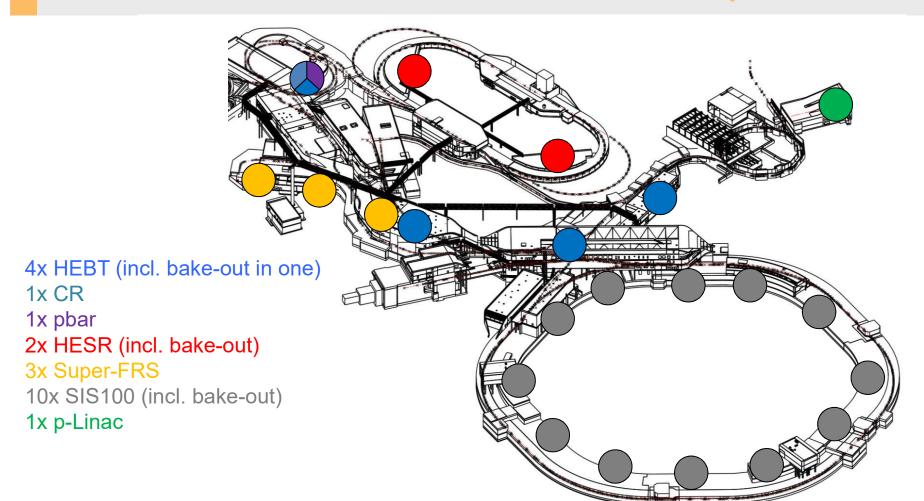
Bake-Out Control System (example CRYRING)





Vacuum Supply Areas (Electronic rooms) Beam Vacuum





Vacuum controls and controllers for beam vacuum and bake-out are distributed over 22 different electronic rooms at FAIR to keep cables "short". But still the lenght is up to ~300m in some cases.

Vacuum System SIS100





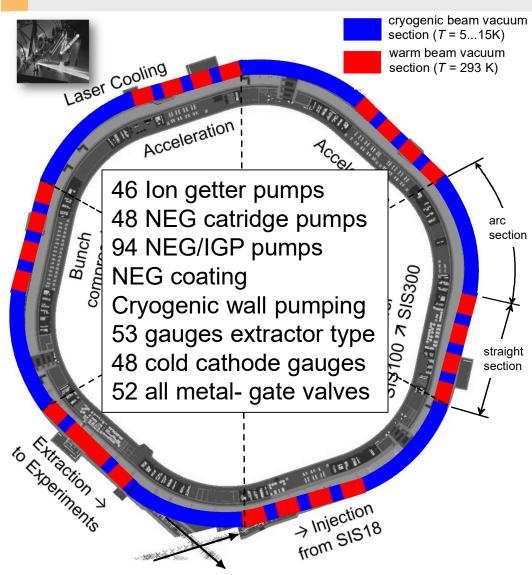
- 46 vacuum sectors
- ~895 m (82%) beam vacuum system will be operated at cryogenic temperatures (5...15 K), → 23 cryogenic sections (6 long arcs à 135 m, & 17 short straights à ~5 m)
- ~187 m (18%) are designed as bakeable room temperature operated UHV system
 → 23 straight warm sections (22 à ~7 m + 1 à ~19 m)

Average residual hydrogen density must be $N_{\text{max}} < 8.10^{+11} \text{ m}^{-3} (\text{H}_2)$

accepting 2% beam losses (aim for reference cycle RIB cycle 2.7GeV U²⁸⁺)

Maximum allowed average beam vacuum pressure must be

→ p_{cold} (H₂) < 1·10⁻¹² mbar (*T* = 10K) → p_{warm} (H₂) < 3·10⁻¹¹ mbar (*T* = 293K)



SIS100: Dipole & Quadrupole Chamber Design



The dipole and quadrupole chambers represent 81% of the total surface in the cryogenic sectors.

Problem:

Fast ramping of the magnets induces eddy currents

- The chamber walls are heated up.
- Generation of additional harmonics in field.

Chamber design was optimized in terms of:

- Low wall temperatures during magnet ramping to assure effective H₂ cryopumping
- field quality (additional harmonics)
- beam dynamic aspects (e.g. impedances)

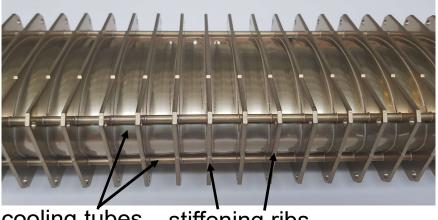
Solution:

- Thin-walled chamber (d = 0.3 mm) with ribs for stiffening
- Special stainless steel Böhler P506 (X 2 Cr Mn Ni Mo N 19 12 11 1) with μ_r = 1.002 at 4.2 K [also used for LHC beamscreen]
- Cooling of chamber with supplementary cooling tubes

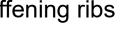
Dipole Chambers SIS100

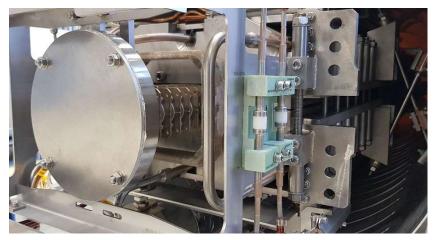


L~3,4m Aperture: 120x60mm² Bending angle 3.33°



cooling tubes stiffening ribs





Status

- Series production running at Pink Vakuumtechnik. ٠
- 55 out of 115 chambers delivered
- Integration on dipole magnets will start 02/2021

FAIR GmbH | GSI GmbH

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Quadrupole chambers SIS100







Status

- Elliptical Chambers series production at Research Instruments ongoing, 12pcs out of 185pcs produced
- Integration into quadrupole module at Babcock Noell (BNG) started

Development of SIS100 Cryosorption Pumps for Cryogenic Sections



In-house development of a pump prototype with charcoal type SC2

Status:

Contract with ILK Dresden All 87 pumps delivered and tested

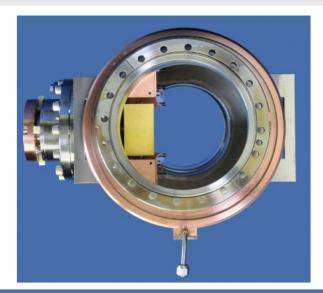


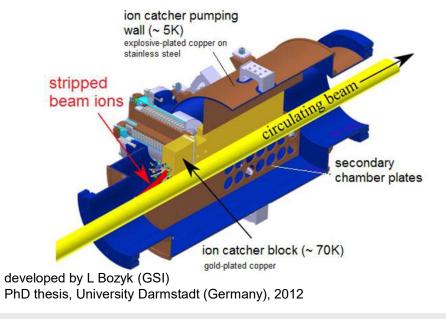
Adsorption pump prototype developed and tested at GSI with outstanding hydrogen pumping characteristics

SIS100 Cryocatcher



- Controlled catching of ionized ions on surfaces with low desorption yield (gold) → most ionized ions are caught by the ion catcher
- Surrounding cold chamber acts as cryopump quickly removing desorbed gases
- Cryocatcher block will be kept at a higher temperature to prevent gases from cryosorbing on the surface of incidence
- Significant reduction of gas desorption → dynamic vacuum effects are suppressed effectively
- Activation and radiation damage of magnets by beam losses are reduced



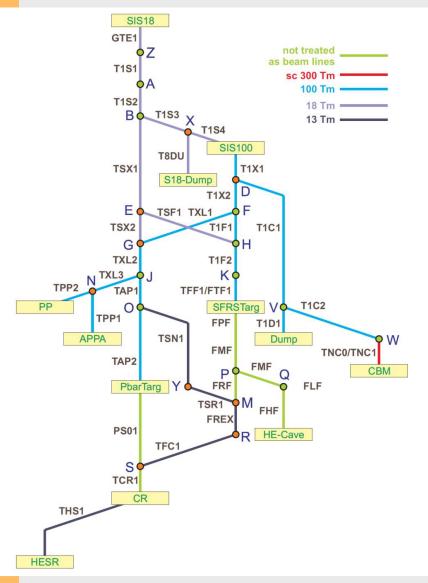




Pictures courtesy of L. Bozyk, Proc. IPAC 2018, ISBN: 978-3-95450-184-7 doi:10.18429/JACoW-IPAC2018-TUPAF084

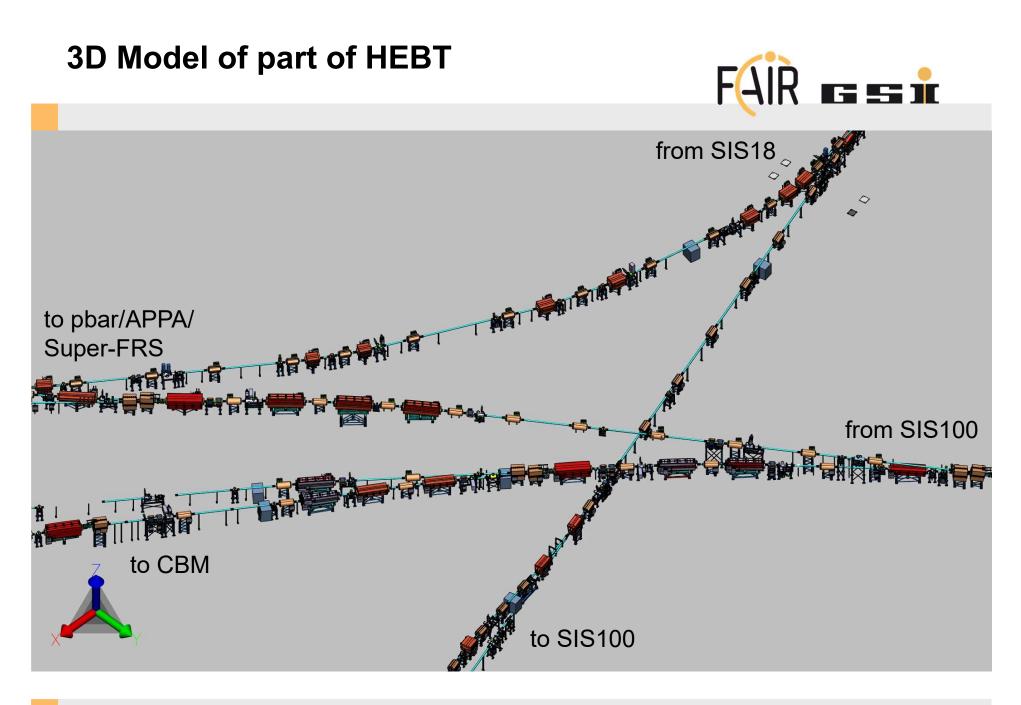
Schematic Layout of HEBT





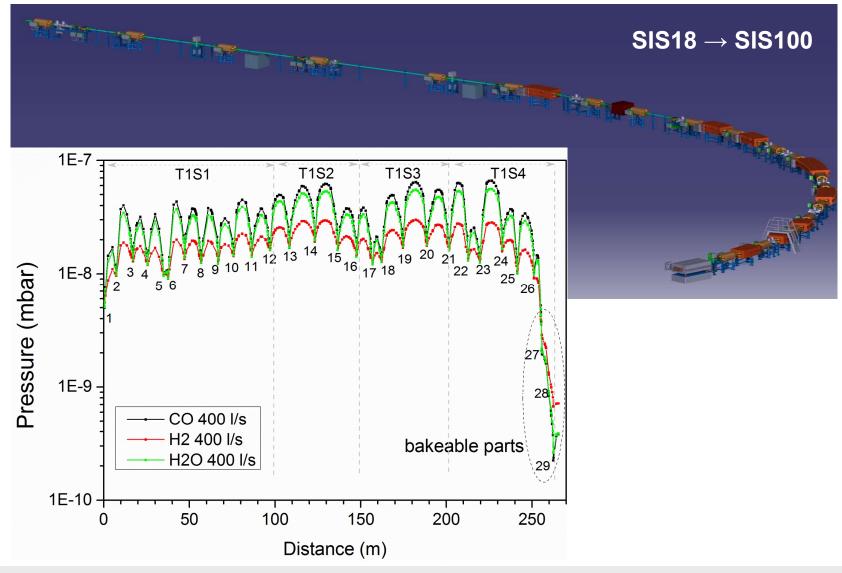
- Beam line length: about 1500 m
- $p \approx 1 \times 10^{-8}$ mbar, non bakeable
- only sections directly connected to SIS100, will be baked up to 300°C to achieve a vacuum of 1x10⁻¹⁰ to 1x10⁻¹¹ mbar
- 46 vacuum sectors, length between 10 and 50 m
- 55 gate valves (Viton and all-metal)
- Pumped by ~150 ion getter pumps
- Beam Pipe Aperture DN100CF DN400CF

Most vacuum chambers to be produced by Budker Institute of Nuclear Physics BINP, Russia



Pressure Profile Simulations of HEBT (using MOLFLOW+)





Dipole Chambers of HEBT produced by BINP (Russia)



- All 51 Chambers of Batch 1 delivered to GSI, SAT passed, 10 installed in magnets LUKAS????
- Batch2&3 (~280 additional magnet vacuum chambers)
- contracted, chambers under production



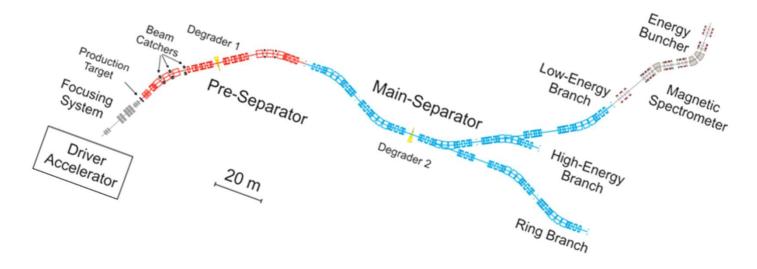






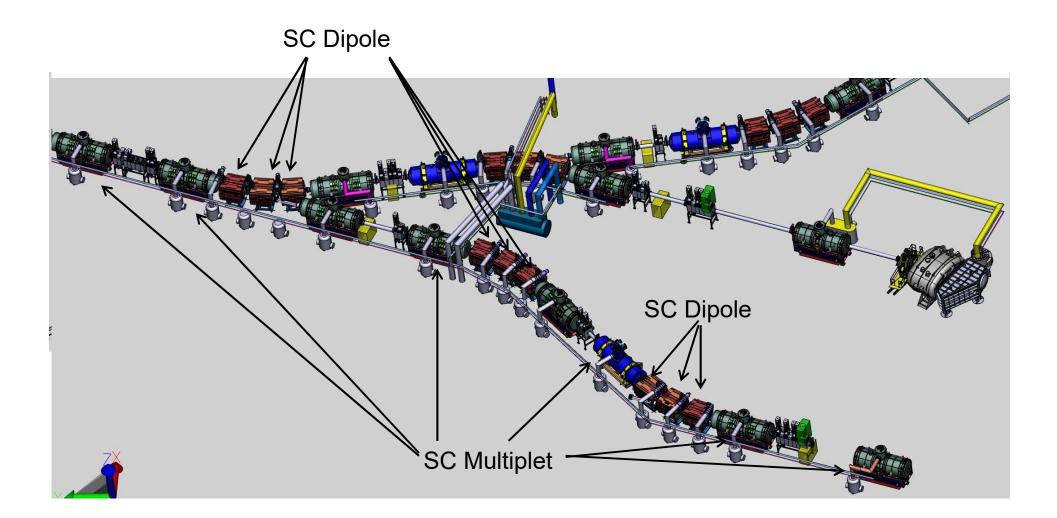
Schematic Layout of the Super-FRS FAR == 1

- High radiation at target area and first separator stage
- Large aperture vacuum chambers and valves (DN400), normal conducting and superferric magnets (insulation vacuum)
- Total length: ~350 m
- Required vacuum: ~ 1x10⁻⁶ 1x10⁻⁷ mbar
- Complex vacuum system due to remote handling in target area (pillow seals and inflatable bellows) and large number of focal plane chambers (20 pcs) with a lot of insertions for the experiments
- 21 diagnostic chambers, 21 standard sc dipole chambers and most of other chambers to be produced by Budker Institute of Nuclear Physics (BINP) Russia, contracts signed
- Pumped by combination of ~55 ion getter pumps & ~30 TMPs (1000l/s)





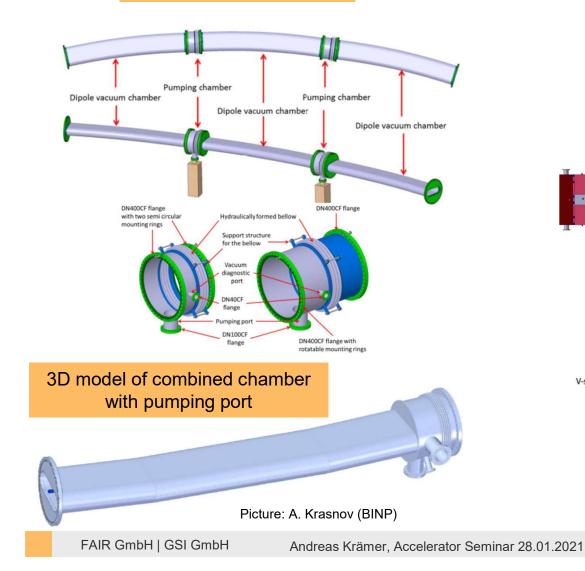




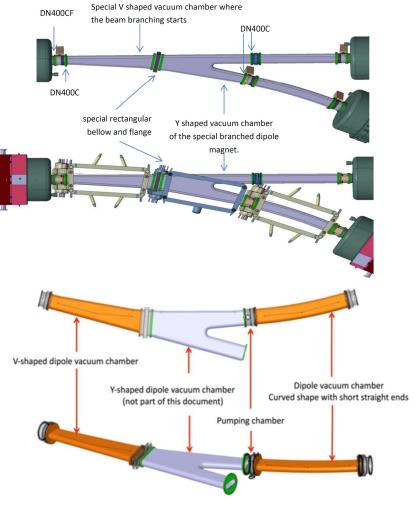
SuperFRS SC Dipole Chambers



Standard Dipole Stage



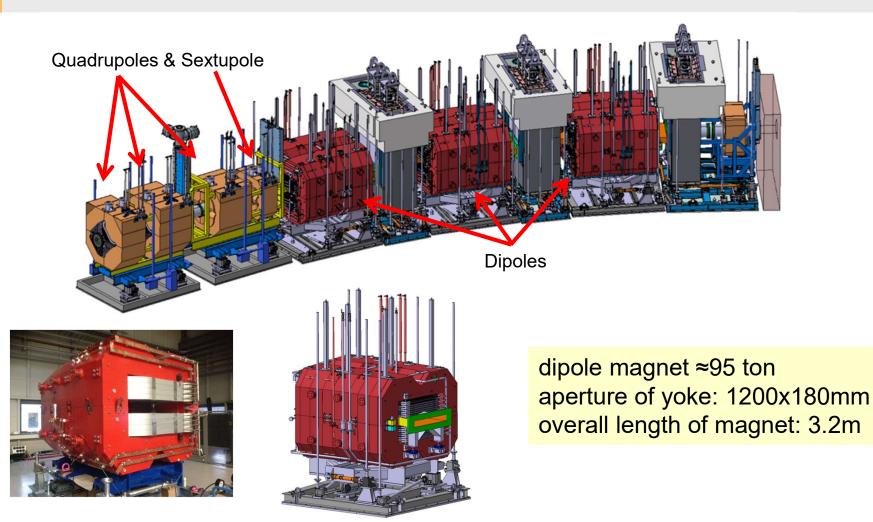
Branching Dipole Stage



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Chambers for Radiation Resistant Dipole Magnets in Target Area SuperFRS

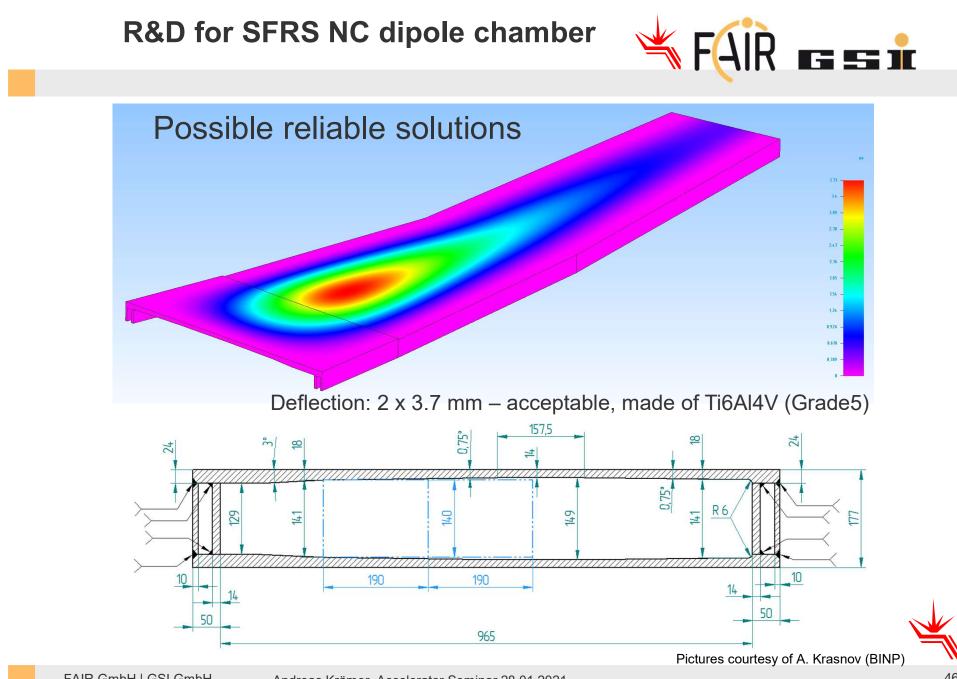




Problem: Dipole chamber will absorb P = 3 W/cm², Energy 4.5 J per pulse

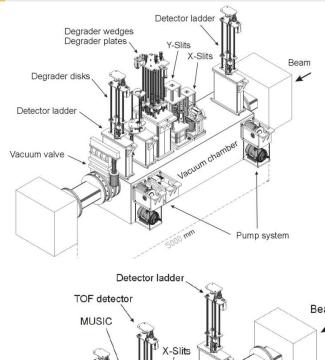
FAIR GmbH | GSI GmbH

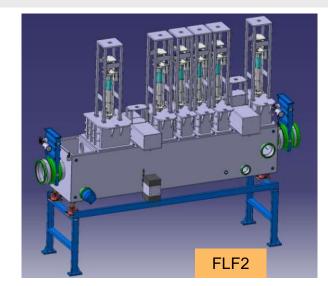
Andreas Krämer, Accelerator Seminar 28.01.2021

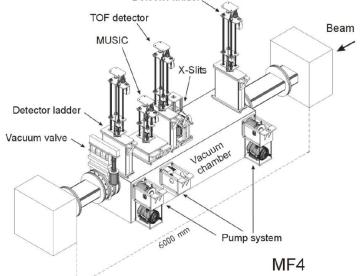


SuperFRS Diagnostic Chambers



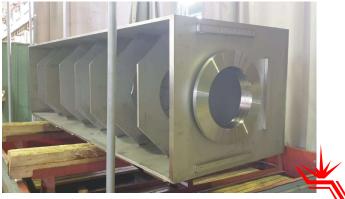








FoS is produced@BINP! Shipment to FAIR in Q1/2021

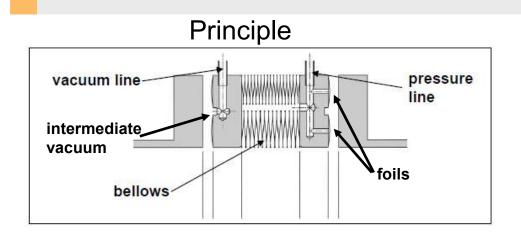


Pictures courtesy of A. Krasnov (BINP)

Andreas Krämer, Accelerator Seminar 28.01.2021

Remote Controlled Pillow Seal for Super-FRS

(Transparancy provided by Super-FRS group)

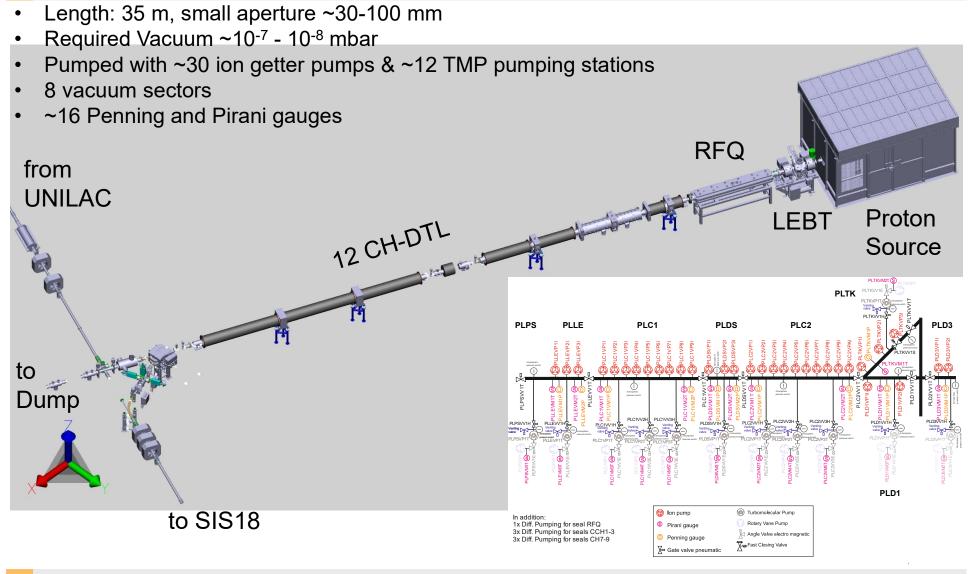






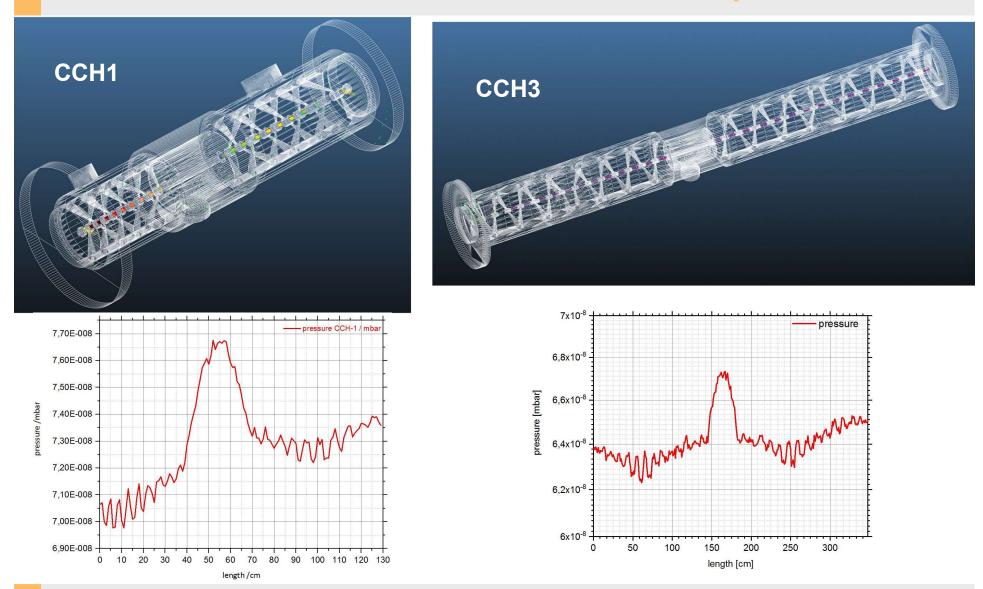
Proton-LINAC (p-Linac)





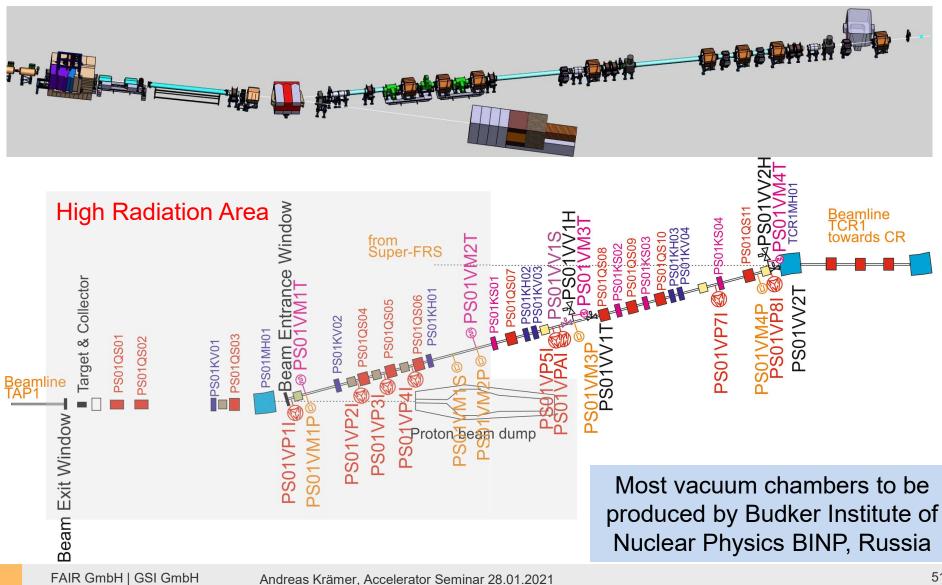
Vacuum Simulation p-Linac





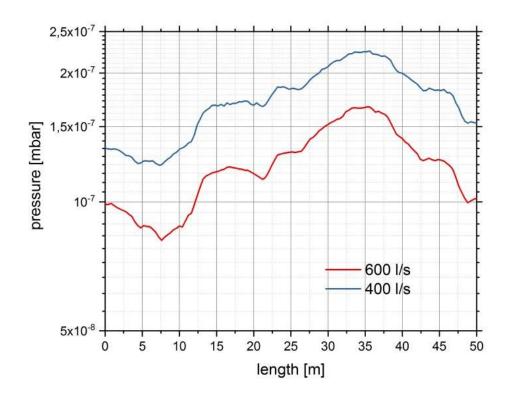
pbar-Separator: 3D Model and Vacuum Layout





pbar-Separator Pressure Profile Calculations (MOLFLOW+)

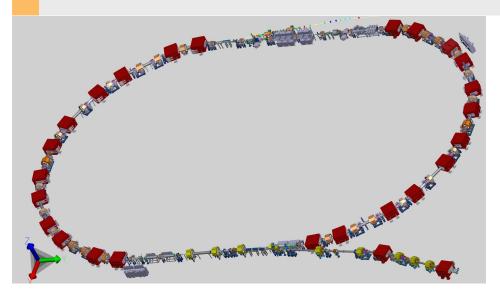




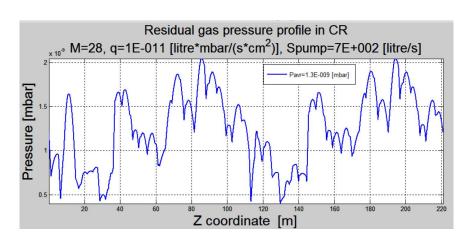
- Required Vacuum ~10⁻⁸ mbar
- Large Aperture Vacuum Chambers with d=400mm
- 2 vacuum sectors
- Pumped by eight ion getter pumps

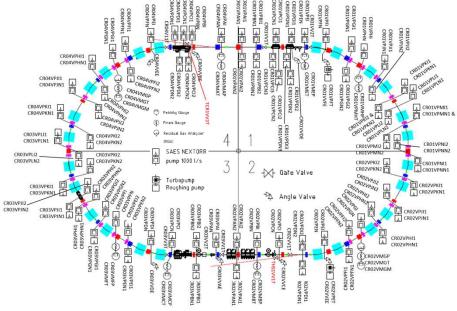
Collector Ring (CR) (Design & Construction by BINP)





- Circumference: 225m (130m magnets)
- Required vacuum for beam life time for heavy ion and antiproton operation of 100 s: p≈10⁻⁹mbar => unbaked
- Beam pipe aperture: 180 480 mm
- Narrow Space in beam direction
- Use of 75 SIP/NEG Cartridge Combination pumps
- 6 vacuum sectors

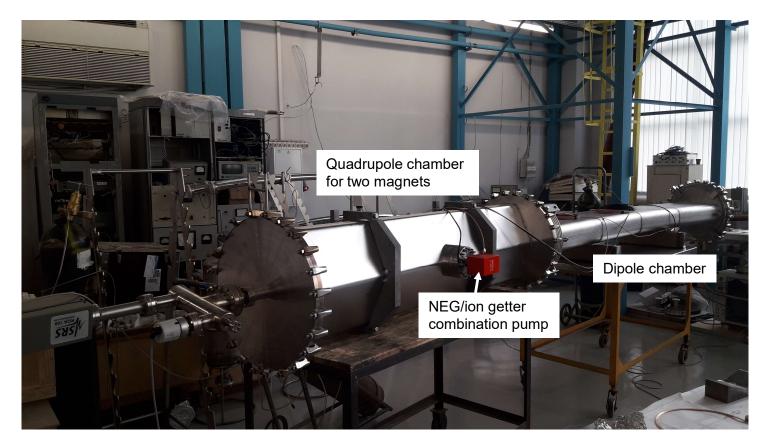




Mock-up installation at BINP



2 pumps for dipole + quadruple chambers – average pumping 'density' per meter in CR Pressure level **2.3E-9** mbar after **1 month** pumping and 3 getter activation



Picture courtesy of A. Krasnov (BINP)

High Energy Storage Ring (HESR) (Design and Construction by FZ Jülich)

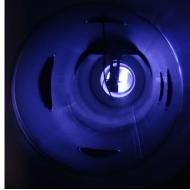


later: electron average pressure range: 1 x 10⁻⁹ ... 1 x 10⁻¹² mbar at RT • 22 sections (incl. 2 for E-Cooler, 1 for PANDA), all separated with all-metal gate valves (max. section length 45 m) bakeable (except of experimental sections) mobile pumping stations roughing only, with oil-free forepumps • beam pipe DN93x2mm, AISI 316LN with low hydrogen content, low permeability ion getter pumps: ~200 NEG Catridge pumps: ~90 NEG coating of dipole chambers

NEG coating of dipole chambers @GSI













Thank you for your attention!!!!

Acknowledgement:

The author would like to thank all the colleagues from GSI, FAIR, FZ Jülich and BINP.